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P A T E N T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Toshiharu DAI, et al.

Serial No.: 10/774,529

Group Art Unit: 2818

Filed: February 10, 2004

Examiner: Chuong A. Luu

For : SEMICONDUCTOR WAFER PROCESSING METHOD

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached Australian Patent Office Search Report. Copies of the references are also enclosed.

Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033773 M 064	SERIAL NO. 10/774,529
	APPLICANT: Toshiharu DAI, et al.	
	FILING DATE February 10, 2004	GROUP ART UNIT 2818

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	20020031863	March 14, 2002	Nakata et al.			
	AB	6,511,895	January 28, 2003	Koma et al.			
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AH	2003-007648	1/10/2003	Japan			X	
	AI	2002-353170	12/6/2002	Japan			abstract	
	AJ	WO 02/51217	6/27/2002	WO				
	AK	0 981 156	7/14/2004	EP				
	AL							
	AM							
	AN							
	AO							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AP	Australian Patent Office Search Report (mailed December 9, 2005) via IPOS (Singapore)
AQ	Australian Patent Office Written Opinion (mailed December 9, 2005) via IPOS (Singapore)
AR	

EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.